
In re Application of:)
)
Shinji MAEKAWA et al.)
)
Serial No.: 10/827,457)
)
Filed: April 19, 2004)
)
For: Method For Forming Pattern And)
Drop Discharge Apparatus)
)
Examiner: Marianne L. Padgett)
)
Art Unit: 1792)
)
Confirmation No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT F (AFTER FINAL)

Applicants have the following response to the Final Rejection of July 23, 2008, a RCE being filed herewith.

Please amend the above-identified application as follows: